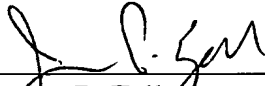


IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicants: Kim
Serial No.: 10/032,687
Filed: December 28, 2001
For: METHOD OF FORMING
WIRING IN SEMICONDUCTOR
DEVICES
Group Art Unit: 2822
Examiner: Maria F. Guerrero

I hereby certify that this paper (or fee) is being
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January 15, 2003


James P. Zeller
Reg. No. 28,491

REQUEST FOR APPROVAL OF DRAWING CHANGES

Commissioner for Patents
Washington, DC 20231

Sir:

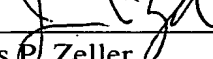
Please enter the following changes to the drawings as indicated in red on the attached
copy thereof. Specifically, please label Figs. 1A-1D and Fig. 3 with the legend "Prior Art"
and add new drawings Figs. 4A-4D.

APPROVED
MG
3-31-03

January 15, 2003

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN

By: 
James P. Zeller
Reg. No. 28,491
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